

# Very High Parallel-Plane Surface Electric Field of 4.3 MV/cm in Ga<sub>2</sub>O<sub>3</sub> Schottky Barrier Diodes with PtO<sub>x</sub> Contacts

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**Introduction**  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> has emerged as a potentially-disruptive wide-bandgap semiconductor material for high power applications, largely due to its high breakdown electric field of  $\sim 8$  MV/cm. To access the full benefit of Ga<sub>2</sub>O<sub>3</sub>, a high electric field close to the breakdown field should be sustained in devices under reverse blocking. This is a challenging task, especially given the fact that functional p-n homojunctions might never be feasible in Ga<sub>2</sub>O<sub>3</sub>. As a result, alternative reverse blocking junctions, such as Schottky barriers [1], p-n heterojunctions [2] and MIS-structures with high- $\kappa$  dielectrics [3] are being investigated. Among them, Schottky barriers have highly-desirable advantages, including less stringent requirements on the interface quality compared to p-n heterojunctions, as well as an absence of reliability concerns – an issue in dielectrics.

However, the reverse leakage current under high field in Schottky barriers is often limited by Fowler-Nordheim tunneling or field emission thus the accessible surface electric field is typically below 3 MV/cm. For Ga<sub>2</sub>O<sub>3</sub>, large Schottky barrier heights over 2 eV are shown possible with oxidized metal contacts [4], where the leakage current can be effectively reduced. In this work, we demonstrate that with a barrier height of  $\sim 1.8$  eV from oxidized platinum (PtO<sub>x</sub>) Schottky contacts, field-emission induced leakage current is dramatically reduced, and a parallel-plane surface electric field of 4.3 MV/cm is reached, *the highest among all Ga<sub>2</sub>O<sub>3</sub> Schottky barrier diodes (SBDs) to date.*

**Experimental Process** As shown in Fig. 1, PtO<sub>x</sub> SBDs were fabricated on a (201) Sn-doped  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> substrate, which has a net doping concentration of  $1.55 \times 10^{18}$  cm<sup>-3</sup> as determined from *C-V* measurements (Fig. 2). A Ti/Au ohmic contact was first deposited on the backside of the substrate. PtO<sub>x</sub> Schottky contacts were deposited by reactive DC sputtering in the presence of an Ar and O<sub>2</sub> mixture, followed by the deposition of a Pt capping layer. Subsequently, a self-aligned dry etching (0.3  $\mu$ m) process was performed for edge termination. For comparison, regular Pt SBDs were also fabricated with a similar process. All measurements were performed at room temperature (RT, 25°C).

**Results and Discussion** Fig. 3 shows the  $1/C^2$ -*V* plot, where a barrier height ( $q\phi_B$ ) of 2.19 eV is extracted from the PtO<sub>x</sub> SBDs. This value is 0.8-eV higher than that of the Pt SBDs (1.42 eV). As expected, PtO<sub>x</sub> SBDs exhibit a higher turn-on voltage (Fig. 4). The barrier height extracted from the *I-V* plot is 1.79 eV from the thermionic emission (TE) model considering the correction for image-force lowering (IFL), lower than the  $q\phi_B$  extracted from the *C-V* method, likely due to barrier-height inhomogeneity. As shown in Fig. 5, the reverse leakage current is significantly reduced in the PtO<sub>x</sub> SBDs compared with the Pt SBDs. As a result, the reverse voltage at 100 mA/cm<sup>2</sup> in the PtO<sub>x</sub> SBD reaches 31 V, corresponding to a parallel-plane surface electric field of 4.3 MV/cm. The reverse *J-E* characteristics is analyzed using our numerical reverse-leakage model, which is based on WKB-tunneling probability with IFL considered. An excellent match is observed between the measured and calculated *J-E* characteristics, with the barrier height as the only fitting parameter (Fig. 6). Fowler-Nordheim (F-N) plot ( $J/E^2$  vs.  $1/E$ ) shows linear behaviors for both diodes at RT, indicating that field-emission is the dominant leakage mechanism (Fig. 7). Barrier heights extracted from *C-V*, forward and reverse *I-V* measurements show decent agreements (Fig. 8). We have developed a numerical model to calculate the “practical” maximum electric field ( $E_{\max}$ ) defined at two maximum reverse current densities: 1 and 100 mA/cm<sup>2</sup>, as a function of the barrier height. As shown in Fig. 9, the experimentally measured  $E_{\max}$  for Pt and PtO<sub>x</sub> SBDs, together with data reported in the literature, agrees well with the predictions by our numerical model.

**Conclusion** A dramatic reduction of the reverse leakage current and an increase of the surface electric field up to 4.3 MV/cm are obtained with PtO<sub>x</sub> contacts due to the increased Schottky barrier height. These results demonstrate the feasibility of effective reverse blocking with a high Schottky barrier in  $\beta$ -Ga<sub>2</sub>O<sub>3</sub>. Furthermore, these results validate a model we introduce here (Fig. 9), which predicts a minimum barrier height of 2.2 eV is necessary to reach a “surface” field of 6 MV/cm. Though these high barrier junctions are not suitable as the Schottky barrier themselves for the sake of a low turn-on voltage desired in SBDs, they are highly desirable to be implemented in Ga<sub>2</sub>O<sub>3</sub> power devices to manage the electric field, especially field crowding and peak field near buried “surfaces”.

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## References

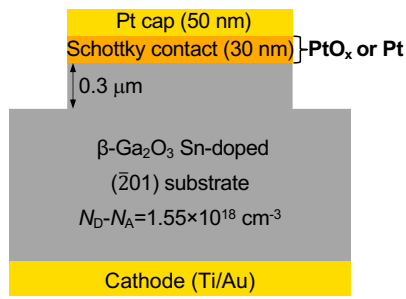
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[2] X. Lu *et al.*, *IEEE-EDL*, vol. 41, p. 449, (2020).

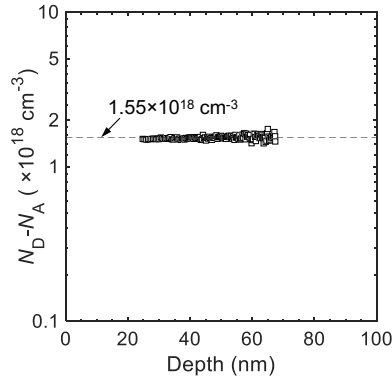
[3] Z. Xia *et al.*, *Appl. Phys. Lett.* 115, 252104 (2019).

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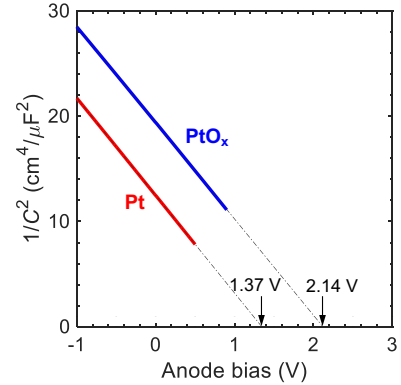




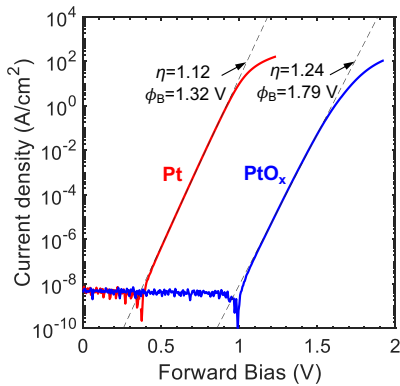
**Fig. 1.** Schematic cross-section of the  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> Schottky barrier diodes with oxidized Pt or regular Pt Schottky contacts.



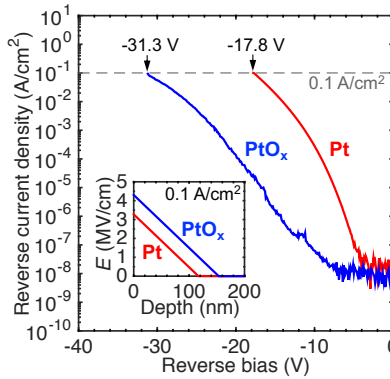
**Fig. 2.** Net doping concentration ( $N_D-N_A$ ) profile extracted from  $C-V$  measurements.



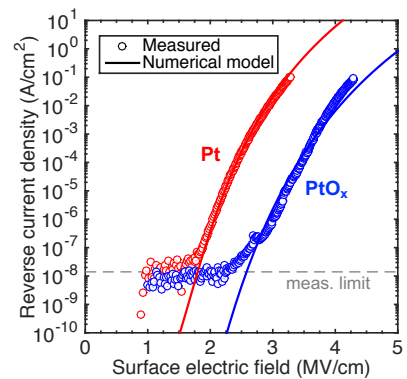
**Fig. 3.**  $1/C^2-V$  plot of the Pt and PtO<sub>x</sub> SBDs. PtO<sub>x</sub> SBDs exhibit a built-in voltage ( $V_{bi}$ ) of 2.14 V, which is 0.77 V higher than the Pt SBDs.



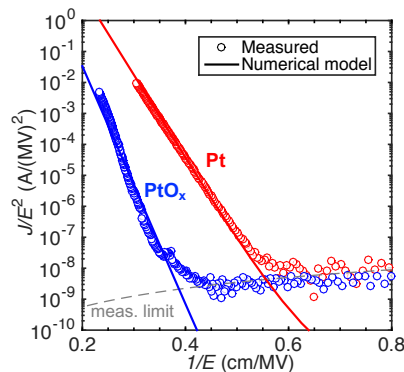
**Fig. 4.** Forward  $I-V$  characteristics of the Pt and PtO<sub>x</sub> SBDs. The image-force-lowering (IFL) corrected barrier heights ( $\phi_B$ ) and ideality factors ( $\eta$ ) are extracted using the thermionic emission (TE) model.



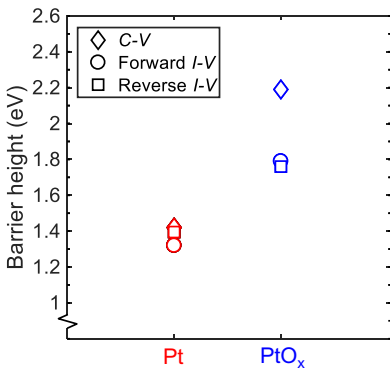
**Fig. 5.** Reverse  $I-V$  characteristics. The maximum reverse voltage at 0.1 A/cm<sup>2</sup> is 17.8 V and 31.3 V for Pt and PtO<sub>x</sub> SBDs, respectively. Inset shows the corresponding electric-field profile at 0.1 A/cm<sup>2</sup>.



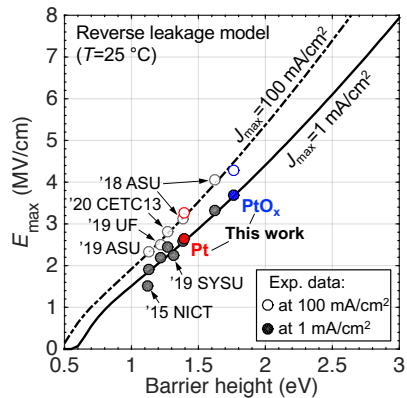
**Fig. 6.** Measured reverse leakage current, along with calculated leakage current using our numerical model as a function of the surface electric field ( $E$ ).



**Fig. 7.** Fowler-Nordheim (F-N) plot of reverse leakage characteristics. The linear behavior suggests a field-emission dominated leakage mechanism.



**Fig. 8.** Barrier heights extracted from  $C-V$ , forward  $I-V$  and reverse  $I-V$  measurements. For PtO<sub>x</sub> contacts, the discrepancy between  $C-V$  and  $I-V$  methods is likely due to barrier-height inhomogeneity.



**Fig. 9.** Calculated and measured practical maximum electric field ( $E_{max}$ ) in  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> SBDs as a function of the barrier height at room-temperature.

